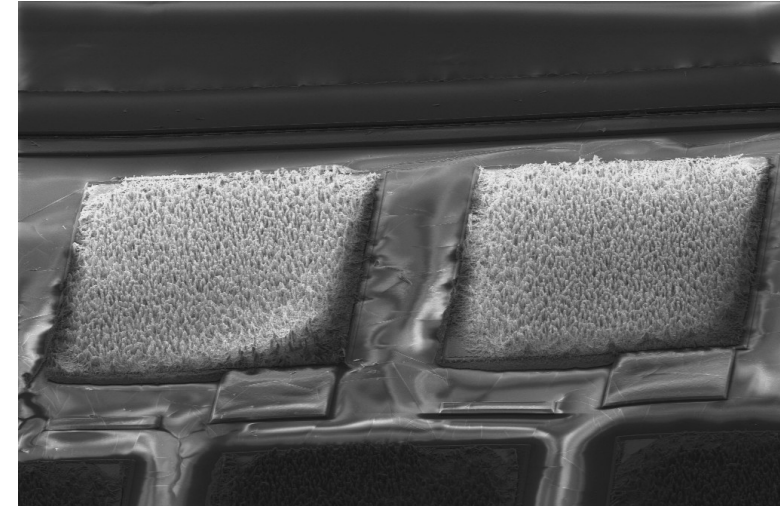
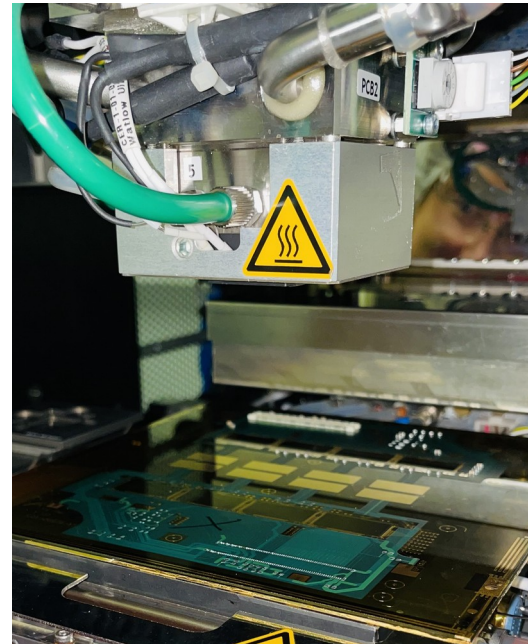
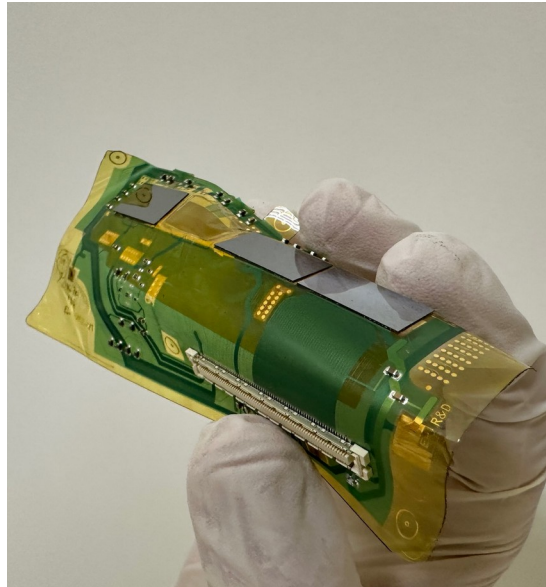
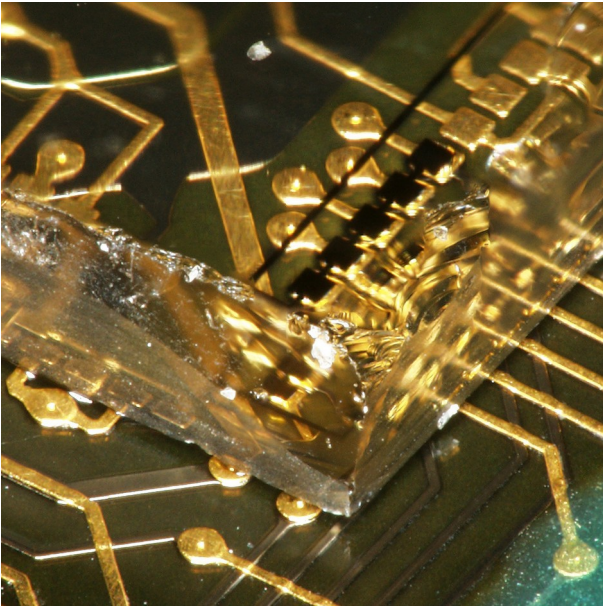


Development of a Novel Low-Mass Flip-Chip-Capable Module Flex PCB

Mateus Vicente Barreto Pinto, Milou Van Rijnbach, Florian Dachs, Valerio Dao, Carlos Solans Sanchez, Heinz Pernegger, Dominik Dannheim, Abhishek Sharma, Maria Sousa, Leyre Flores Sanz De Acedo, Dominik Dobrijevic, Ignacio Asensi Tortajada, Petra Riedler, Abdelhak M. Zoubir, [Julian Weick](#)



Thin-film Flexible PCB

- Concept and design
- First electrical and mechanical tests

Interconnection technologies

- Overview
- Pre-bonding verification

Results and Outlook

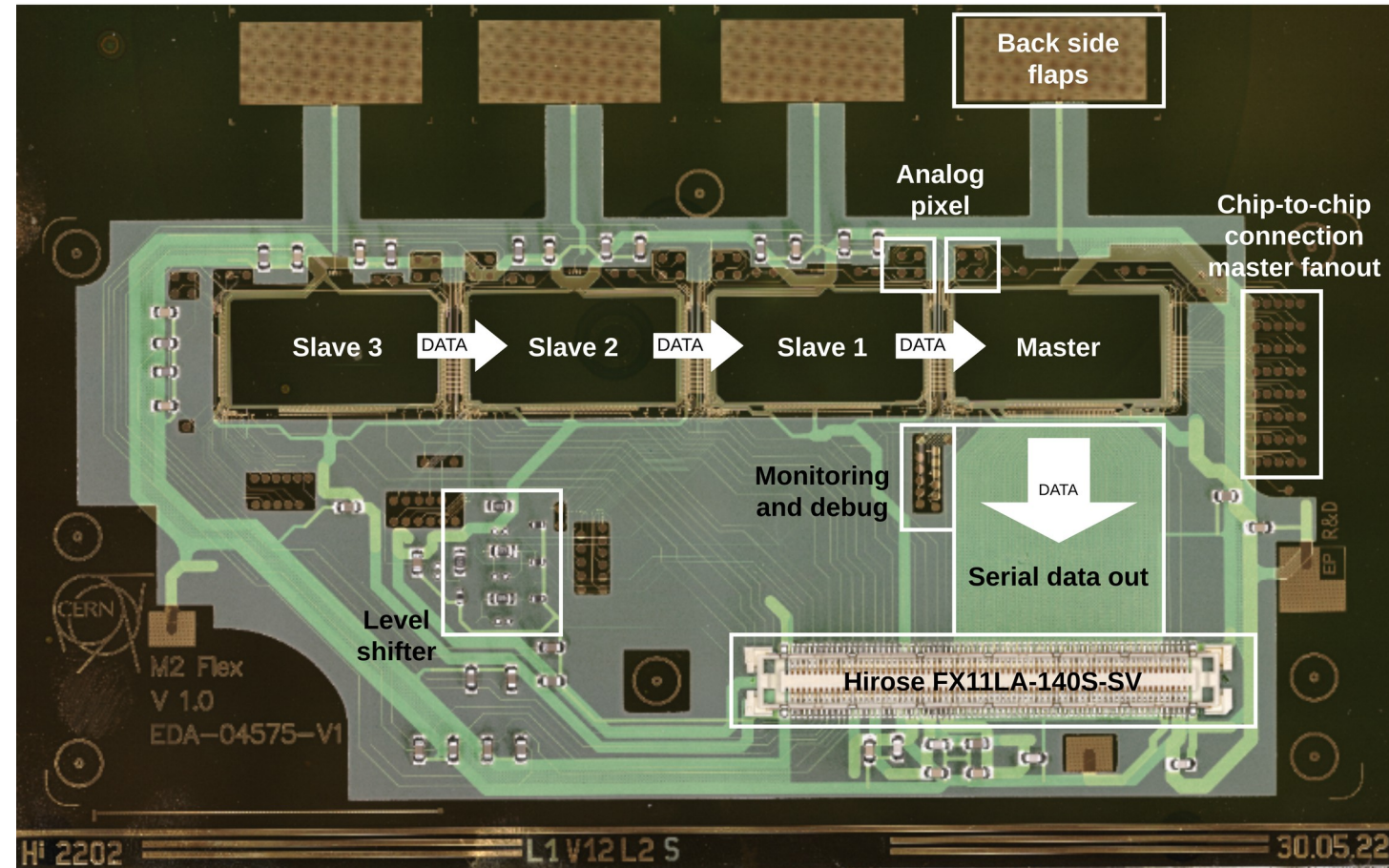
- Forceless flex detachment
- Further development

Goal: Flexible, low material, dense and reliable modules

Flex Demonstrator Overview

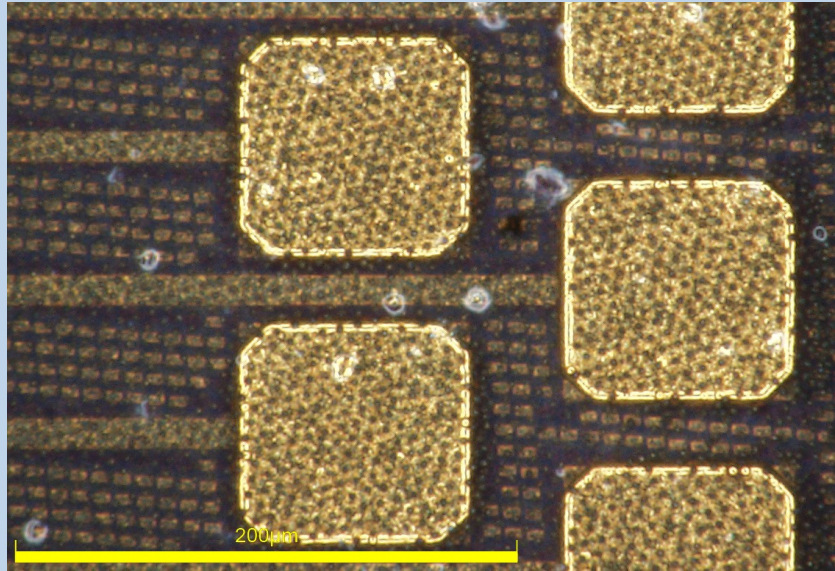
The manufactured flex provides:

- Manufacturing **low-mass**, highly flexible PCB
- **Demonstrating a dense integration of silicon pixel chips**
- **Two-layer** layout $\sim 30\mu\text{m}$ high with $17\mu\text{m}$ trace width and spacing
- **Data transfer from chip-to-chip**
- Individual powering with **500mA per chip**
- 140 pin **connector** for lab tests
- Integrated **back side flaps** providing bias voltage
- Inclusion of **debug pads** and data fan-outs



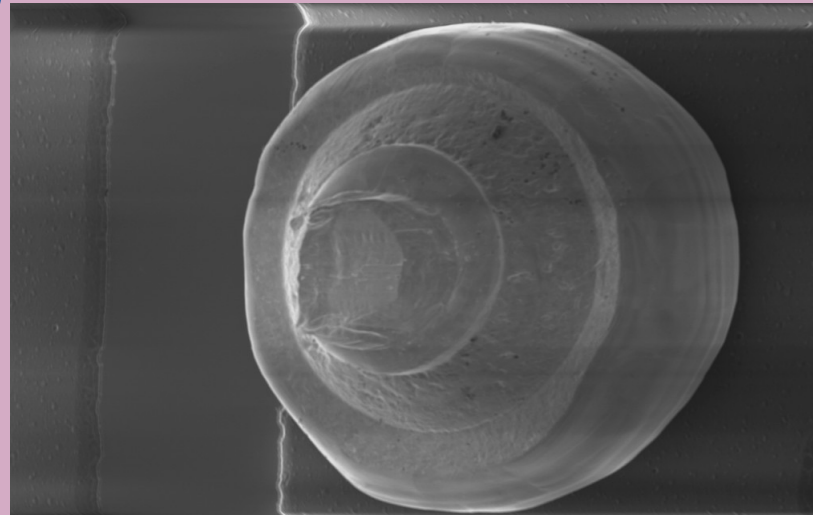
Interconnection Technologies for Flip-chip

ACF



- **Cost effective**
- **In-house** processing
- **No mask** needed

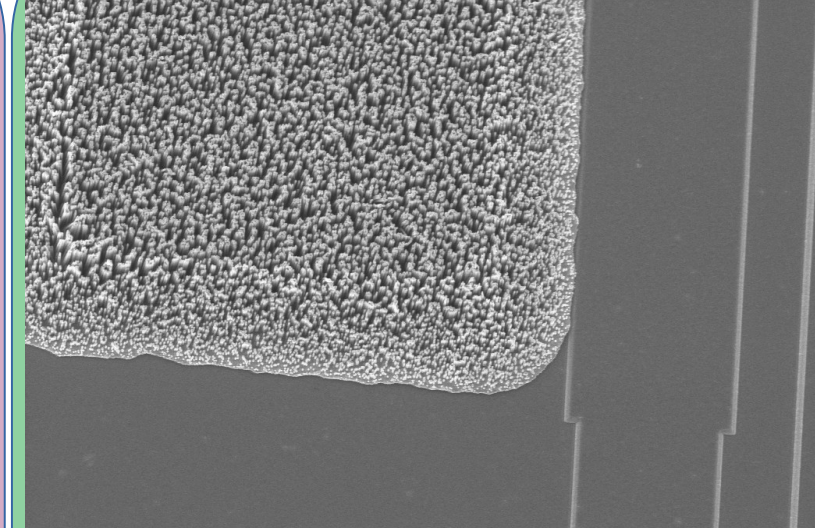
Gold studs



10 μm EHT = 5.00 kV WD = 15.2 mm Signal A = SE2 Sample ID = Malta_2_glass_s_ Aleksandra Bartkowska Date: 17 Nov 2023 Mag = 1.00 K X EN

- **Individual** pad selectable
- **Touch** before bond possible
- **No mask** needed

Nano-wires (NW)



10 μm Stage at T = 11.2 ° Signal A = SE1 WD = 11.33 mm Image Pixel Size = 156.6 nm Mag = 1.75 K X EHT = 10.00 kV

- Applicable for a **wide range of pad and spacing sizes**
- **Glue-free** process available
- **Chip and wafer** level



- **Scalable** on chip-chip or flex-chip
- **Glue support** for mechanical stability
- **Fast** interconnection
- Suitable for **large number of pads**



- **Pre-bonding verification** is a crucial part on the track to flip chip modularization of large modules
- **Successfully tested** full pre-bond verification with powering and reading out chip before bonding
- Compatible with **gold studs** and **nano-wires**
- **Automation** for a larger scale production foreseen

Process steps:

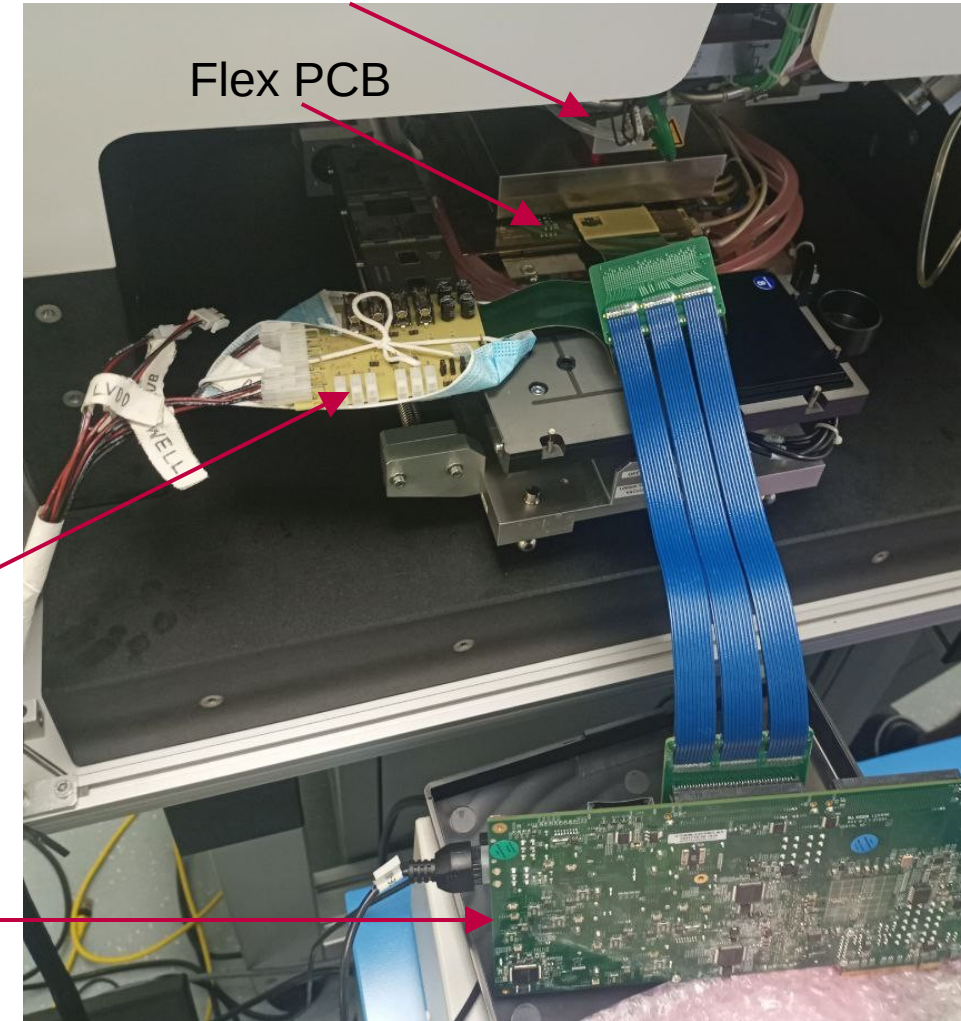
- 1) **Connect** Flex to power and read out
- 2) **Align** chip on bonehead with flex pads
- 3) **Hold** chip on flex with 0.5 x bond force
- 4) **Power up** chip and run **tests**
- 5) If chip OK, start **bonding** procedure, else **replace**

Bond head with chip

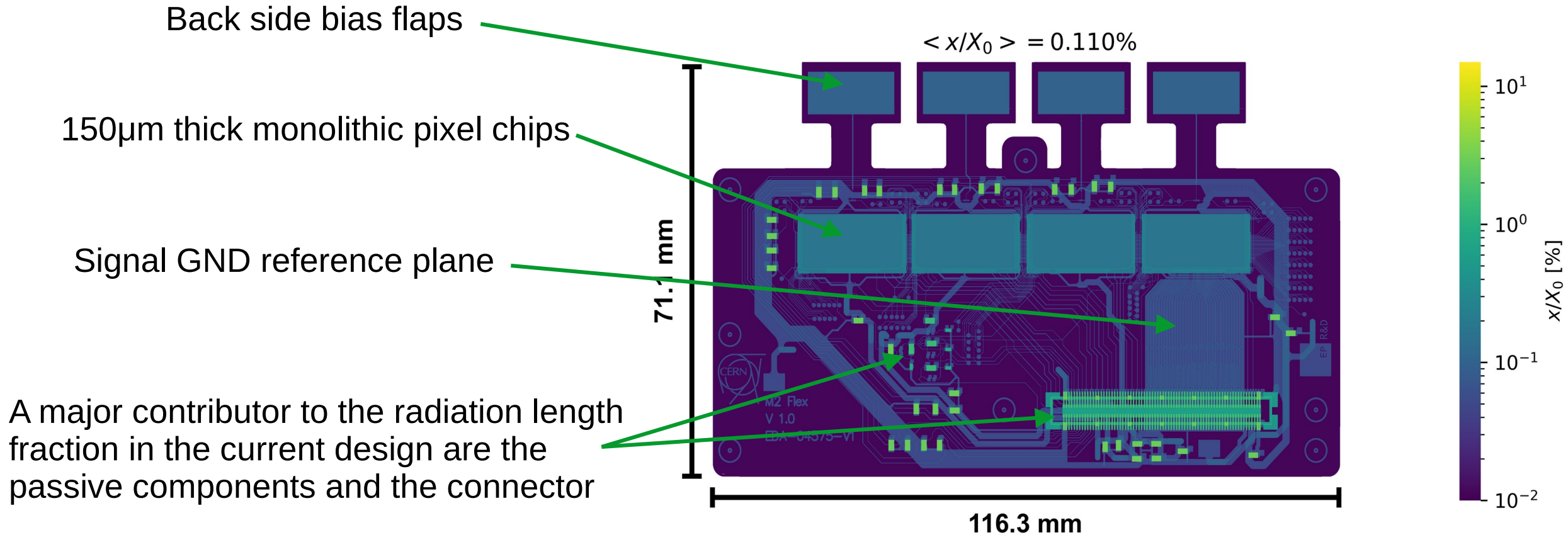
Flex PCB

Power delivery board

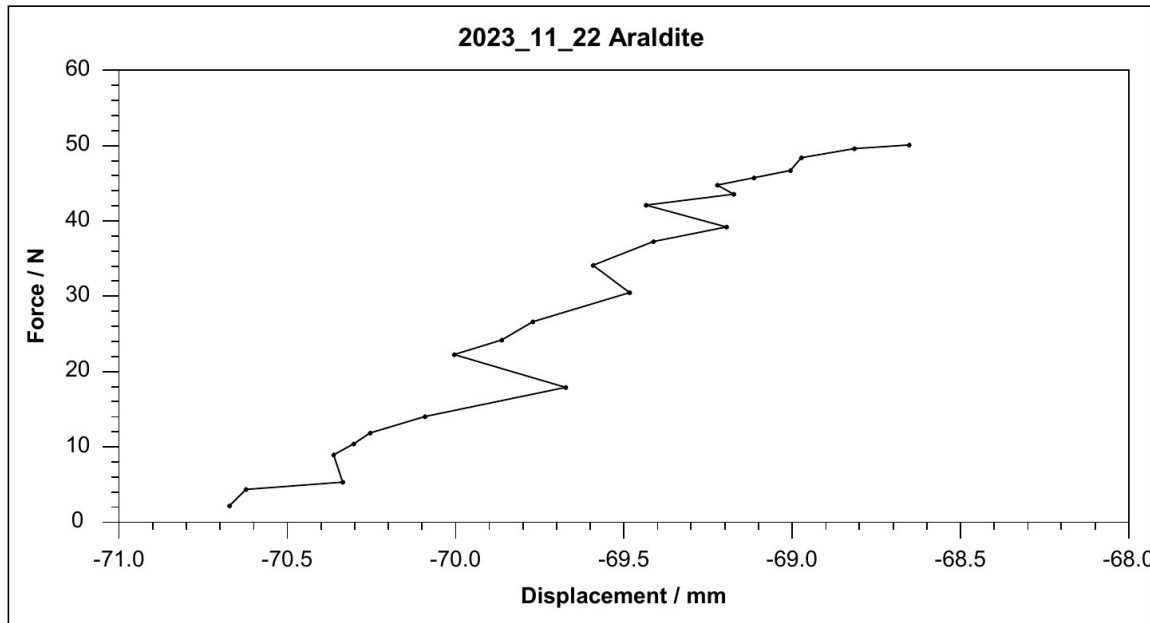
Read out FPGA



Calculated Material Budget

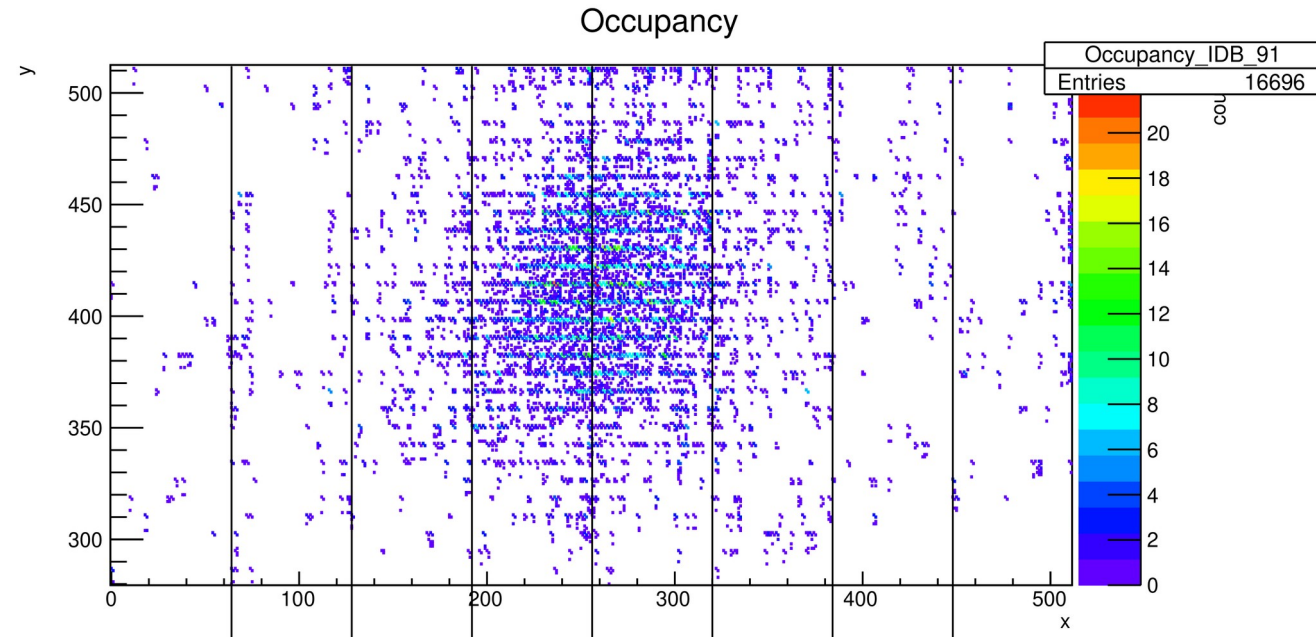


Mechanical



- **Araldite 2011** as under fill
- **Pull force** to detach a chip from the flex **>50N**
- The used under fill is **compatible** with all shown interconnection technologies

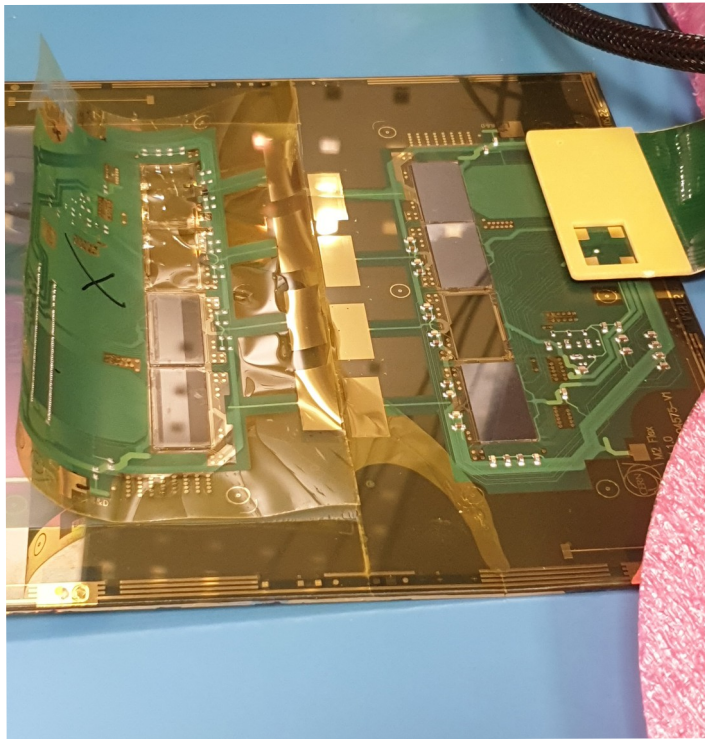
Electrical



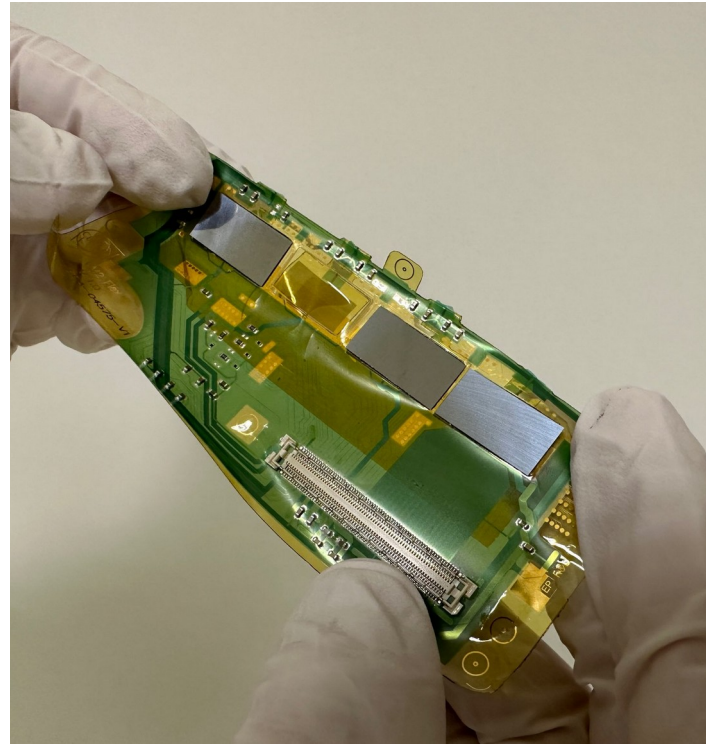
- Hit map of a Sr90 source on master chip bonded to flex
- Demonstrating a **successful communication** with the chip

Detaching Flex

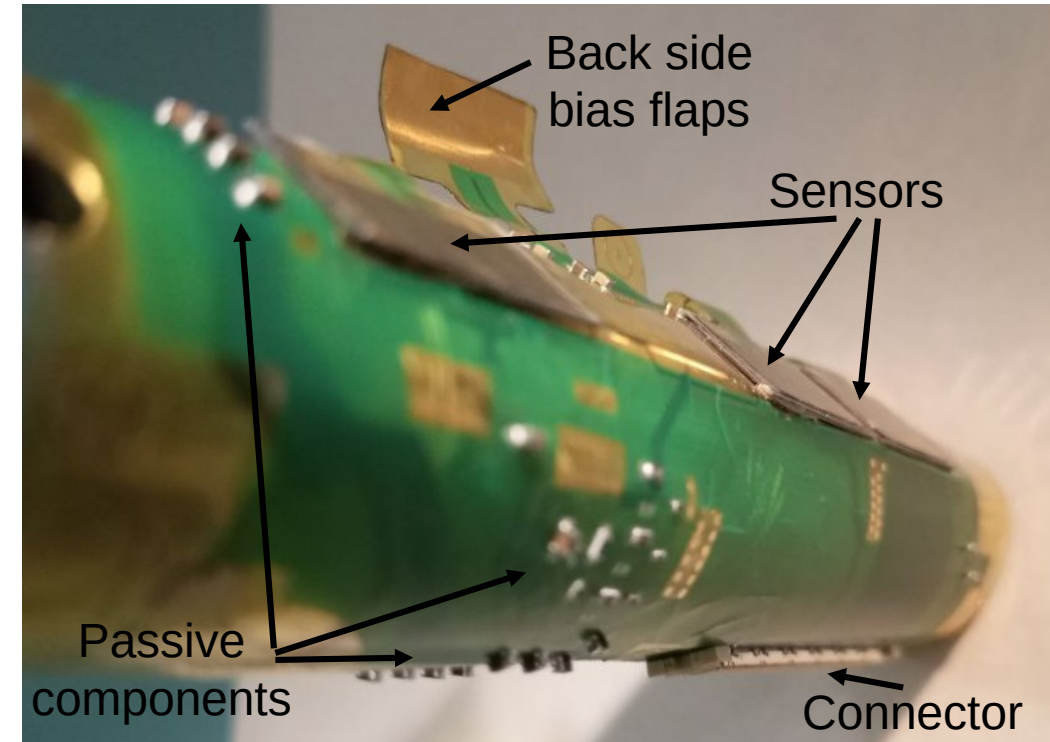
- Detachment from production carrier conducted **after flex assembly**
- **Force needed** for the detachment process, resulting in tension onto the polyamide
- Bonding on production carrier **preserves tolerances** during assembly



Testing and delamination

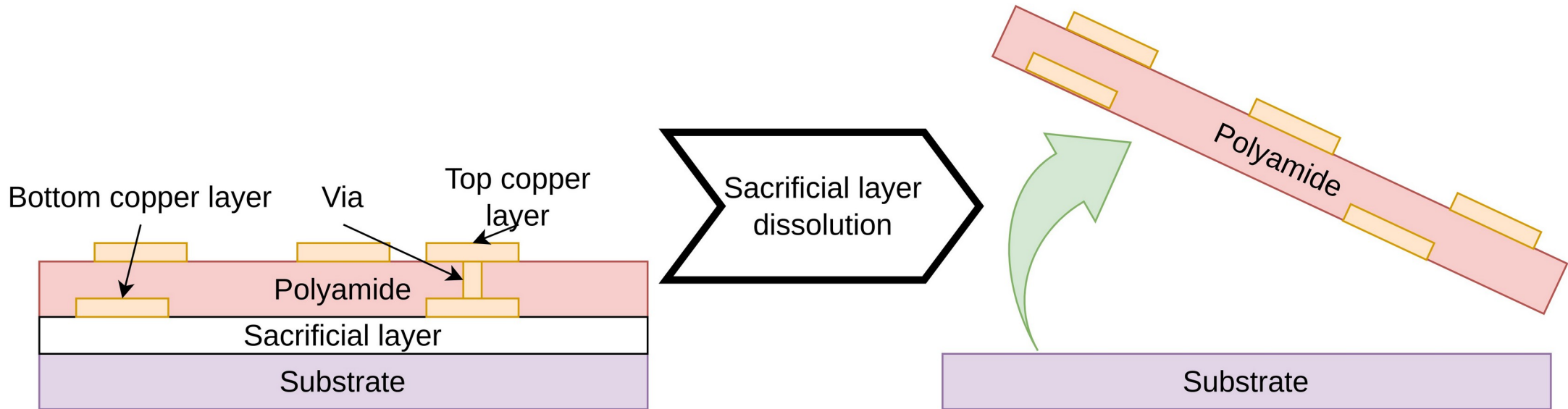


Detached flex



Detached flex around tube

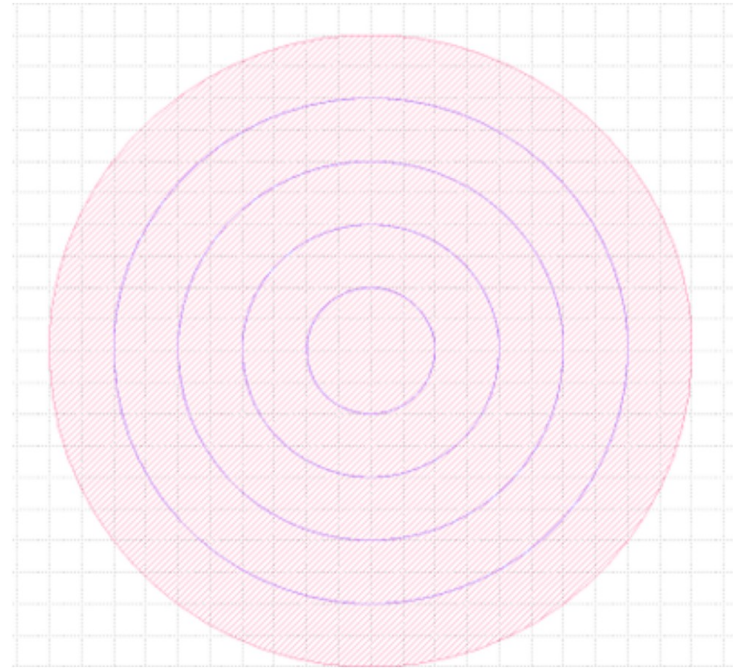
Forceless flex-carrier separation



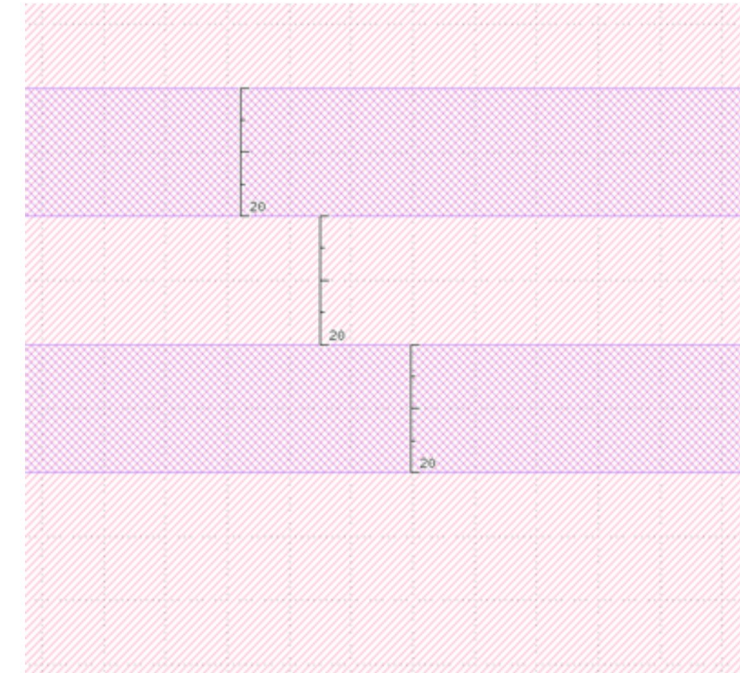
- **Forceless separation** process reducing stresses of the flex during detachment
- **Reducing mechanical deformation** of the flex during the separation process
- Potentially enabling the **manufacturing of pads on top and bottom** of the flex
- Reducing manual labor in **large scale manufacturing** processes
- In a first try, **aluminum** is used as sacrificial layer and **removed by electrolytic corrosion**

Separation prototype - design

- Flex manufactured on **4 inch wafer**
- **4 double ring** construction
- Testing the manufactur ability of **20 μ m track width and spacing**
- Testing **forceless detachment**
- Manufactured by the summer student Maria Sousa at **Campus Biotech**

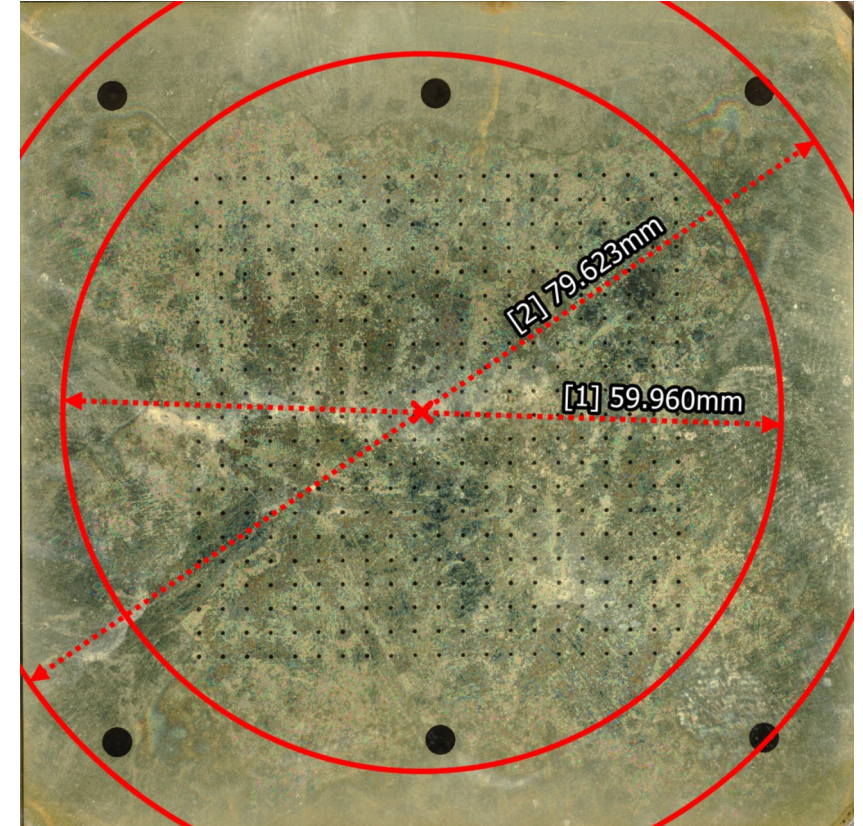
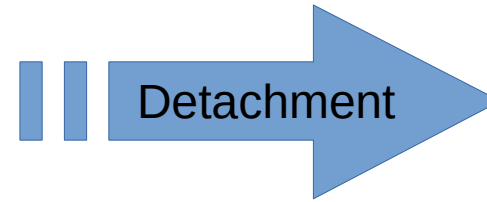
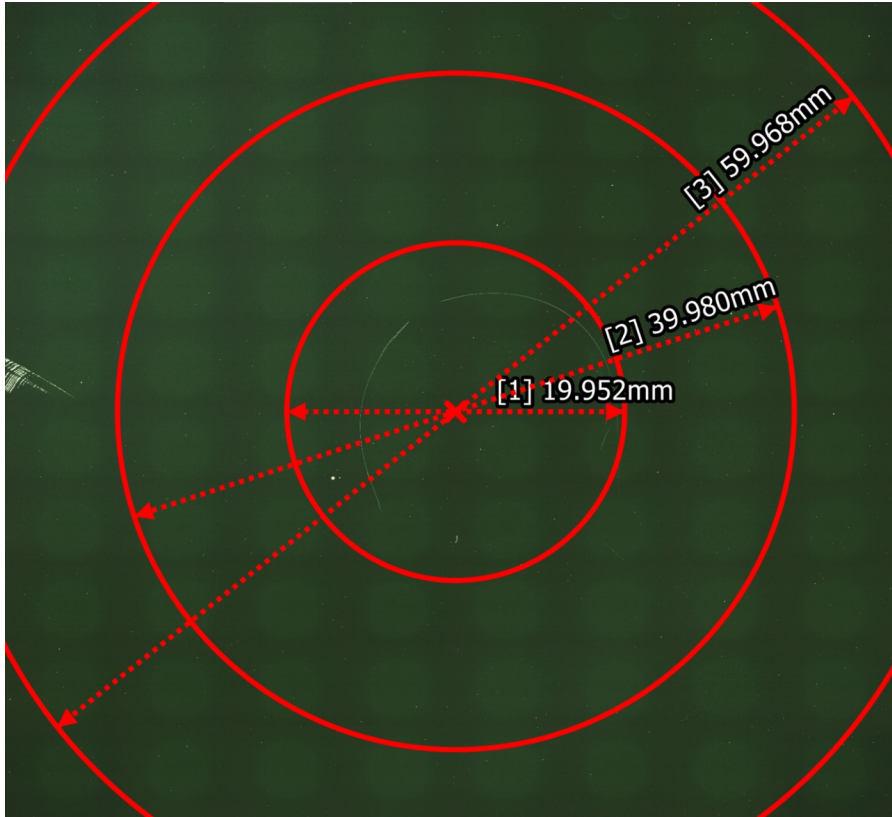


Double ring on 4" wafer



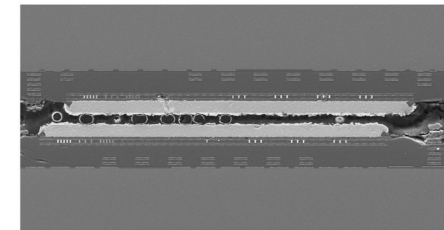
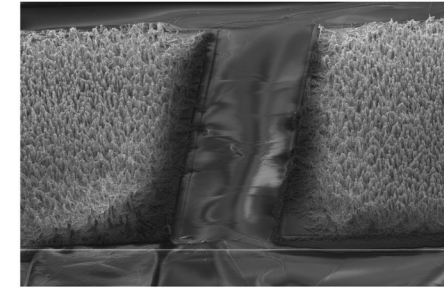
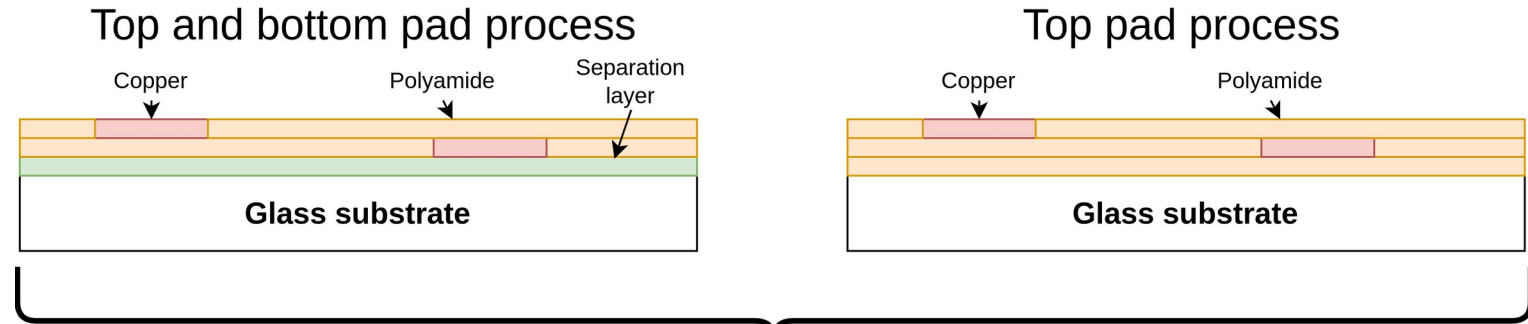
20 μ m track width and spacing

Separation prototype - detachment tests



- Circular test structure on **8 μ m polyamide flex** before and after forceless detachment
- Forceless separation of single layer flex **successfully demonstrated**
- First tests show a **deformation of <0.5%**

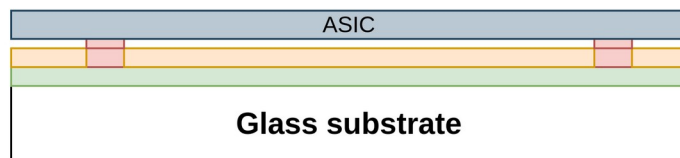
Towards custom fully integrated circuits



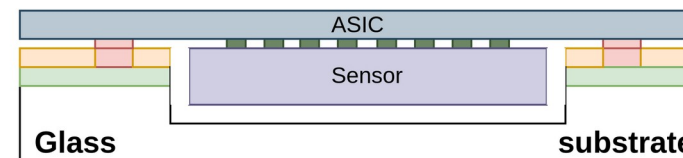
Development of in-house prototyping of flex utilizing 20/20 technology.

+
Nano wires
Gold studs
ACF/ACP

Integration of monolithic sensors



Integration of hybrid sensors



To sum it up

Thin-film Flexible PCB

- Fabricated a **thin film flex** demonstrator
- Demonstrated **forceless detachment**
- Integration and flex are **electrically tested**

Interconnection technologies

- Three interconnection **options**
- **Pre-bond verification** with gold studs

Results and Outlook

- Forceless flex **detachment process**
- Further developments on the **pre-bond verification**

-> **Flexible framework** for the modularization of pixel chips

Thank you very much for your attention